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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	§	
Aaron O. Vanderpool et al.	§	Art Unit: 2891
	§	
Serial No.: 10/789,851	§	Examiner: Asok K. Sarkar
	§	
Filed: February 26, 2004	§	Atty Docket: ITL.1078US
	§	P18386
For: Implanting Carbon to	§	
Form P-Type Source	§	Assignee: Intel Corporation
Drain Extensions	§	

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed August 16, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: November 2, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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